

<b>Notice of References Cited</b>	Application/Control No. 10/788,970		Applicant(s)/Patent Under Reexamination BORKOVSKY ET AL.	
	Examiner Shew-Fen Lin		Art Unit 2166	Page 1 of 1

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*	C	US-7,146,358 B1	12-2006	Gravano et al.	707/4
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**NON-PATENT DOCUMENTS**

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